



AF/FW
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yongjun Hu

Serial No.: 10/771,828

Filed: February 4, 2004

For: PROCESS FOR FORMING A
DIFFUSION BARRIER MATERIAL
NITRIDE FILM

Confirmation No.: 3960

Examiner: Q Hoang

Group Art Unit: 2818

Attorney Docket No.: 2269-6983.5US
(96-0790.05/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

April 8, 2005
Date

Signature

Joseph A. Walkowski
Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. §1.116

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed February 9, 2005, the three-month shortened statutory period for response to which expires on May 9, 2005. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.